## **CLAIMS:**

- 1. For use with a source of electromagnetic energy, a sensor for measuring a measurable parameter, the sensor comprising:
  - an electromagnetic resonator, disposed to receive at least a portion of the electromagnetic energy, the electromagnetic resonator having a dielectric body with a sensing surface responsive to changes in the measurable parameter at the sensing surface and the electromagnetic resonator defining a cavity forming a variable gap that varies in response to the sensing surface and that is positioned such that a resonant frequency associated with an electromagnetic standing wave in the dielectric body and the variable gap changes in response to changes in the measurable parameter.
- 2. The sensor of claim 1, wherein the resonator comprises a dielectric resonator.
- 3. The sensor of claim 1, wherein the resonator comprises a resonant antenna.
- 4. The sensor of claim 1, wherein the resonator comprises a resonant transmission line.
- 5. The sensor of claim 1, wherein the measurable parameter is selected from the group consisting of pressure, temperature, flow rate, material composition, force, and strain.
- 6. The sensor of claim 1, further comprising a measuring apparatus for measuring a repetition rate of the energy.
- 7. The sensor of claim 1, wherein the resonator is external to the source.
- 8. The sensor of claim 1, wherein the resonator is internal to the source, forming a cavity of a mode-locked source.

- 9. For use with a source of electromagnetic energy, a sensor for use in measuring a measurable parameter, the sensor comprising:
  - a resonator having a dielectric body with a variable cavity gap responsive to changes in the measurable parameter at a sensing surface, the resonator defining a resonant frequency of a standing electromagnetic wave in the dielectric body and the variable cavity gap that is dependent upon the measurable parameter at the sensing surface, the resonator being disposed such that a signal from the sensor is a function of the resonant frequency.
- 10. The sensor apparatus of claim 9 wherein the resonator is internal to the source and forms a cavity of the source.
- 11. The sensor apparatus of claim 9, wherein the resonator forms a resonator that is external to the source.
- 12. The sensor of claim 9, wherein the resonator comprises a dielectric resonator.
- 13. The sensor of claim 9, wherein the resonator comprises a resonant antenna.
- 14. The sensor of claim 9, wherein the resonator comprises a resonant transmission line.
- 15. The sensor of claim 9, wherein the measurable parameter is selected from the group consisting of pressure, temperature, flow rate, material composition, force, and strain.
- 16. The sensor apparatus of claim 9, further comprising a measuring apparatus for measuring the frequency of the signal.
- 17. An apparatus for modulating, based on a measurable parameter, the output of a source producing electromagnetic energy, the apparatus comprising:

a coupler coupled to receive the energy; and

- a high Q resonator having a dielectric body with a variable configured to produce an effective dielectric constant that varies in response to changes in the measurable parameter, the high Q resonator coupled to the coupler for receiving the energy and creating an electromagnetic standing wave within the dielectric body and the variable cavity gap at a resonant frequency that is a function of the measurable parameter.
- 18. The apparatus of claim 35, wherein the measurable parameter is selected from the group consisting of pressure, temperature, flow rate, material composition, force, and strain.
- 19. The apparatus of claim 17, wherein the source has a resonator characterized by a first Q value Q1, and the high Q resonator is characterized by a second Q value Q2, that is substantially higher then Q1.
- 20. The apparatus of claim 19, wherein Q2 is at least 100.
- 21. A variable frequency resonator comprising an electromagnetic resonator having a dielectric body and a cavity defining a variable gap, the resonator producing an output at a resonant frequency that is dependent upon the variable gap which is disposed to alter a ratio of stored electric field and magnetic field energy of an electromagnetic standing wave in response to changes in the measurable parameter.
- 22. A method of sensing a measurable parameter, the method comprising:

  providing a resonator characterized by a resonant frequency that is a function of a

  variable gap in an internal cavity of a dielectric body of the resonator, the

  variable gap being responsive to the measurable parameter;
  - supplying electromagnetic energy to the resonator to produce an electromagnetic standing wave in the dielectric body and the variable gap; and

sensing a resonant frequency of the electromagnetic standing wave to determine the measurable parameter.

- A method of sensing a measurable parameter, the method comprising the steps of:

  providing a pulsed electromagnetic signal characterized by a repetition rate;

  providing a resonator having a dielectric body with a variable gap that varies in response to changes in the measurable parameter;

  supplying the pulsed electromagnetic signal to the resonator to produce a pulsed electromagnetic wave pattern in the dielectric body and the variable gap; and sensing variations in the repetition rate of the pulsed electromagnetic signal in response to variations in the variable gap.
- 24. For use with a electromagnetic source, a resonator having a dielectric body with a variable gap that varies in response to changes in a measurable parameter, the resonator receiving electromagnetic energy from the source to produce an electromagnetic standing wave in the dielectric body and the variable gap so that a characteristic of the energy changes in response to variations in the variable gap.
- 25. The resonator of claim 30, wherein the electromagnetic energy is a continuous wave and the characteristic is frequency.
- 26. The resonator of claim 30, wherein the electromagnetic energy is a pulsed energy and the characteristic is repetition rate.
- 27. An electromagnetic resonant sensor comprising:
  - a sensor body; and
  - a cavity within the sensor body having a variable gap between interior surfaces of the sensor body that varies as a function of a measurable parameter, the cavity being positioned within the sensor body so that an electromagnetic standing

wave is formed within the body and the variable gap, and a resonant frequency of the sensor is a function of the measurable parameter.

- 28. The electromagnetic resonant sensor of claim 27 wherein the sensor body is a dielectric material.
- 29. The electromagnetic resonant sensor of claim 28 and further comprising: a conductor on one of the interior surfaces.
- 30. The electromagnetic resonant sensor of claim 29 wherein the conductor is configured to cause the sensor to resonate as a ring resonator.
- 31. The electromagnetic resonant sensor of claim 29 wherein the conductor is configured to cause the sensor to resonate as a transmission line.
- 32. The electromagnetic resonant sensor of claim 29 wherein the conductor is configured to cause the sensor to resonate as a slot antenna.
- 33. The electromagnetic resonant sensor of claim 29 wherein the conductor is configured to cause the sensor to resonate as a dipole antenna.
- 34. The electromagnetic resonant sensor of claim 29 wherein the conductor is configured to cause the sensor to resonate as a port antenna.
- 35. The electromagnetic resonant sensor of claim 28 wherein the sensor body and cavity are configured to resonate at suboptical frequencies.
- 36. An electromagnetic resonant sensor for receiving electromagnetic energy and producing an output based upon an electromagnetic standing wave having a resonant

frequency that is a function of a parameter to be measured, the sensor characterized by a dielectric body with a variable gap that changes dimension as a function of the parameter, the dielectric body and the variable gap being configured so that the electromagnetic standing wave extends within the dielectric body and the variable gap and a change in gap dimension causes a change in the resonant frequency.